

Lecture 26 - 6.012 Wrap-up

December 13, 2005

Contents:

1. 6.012 wrap-up

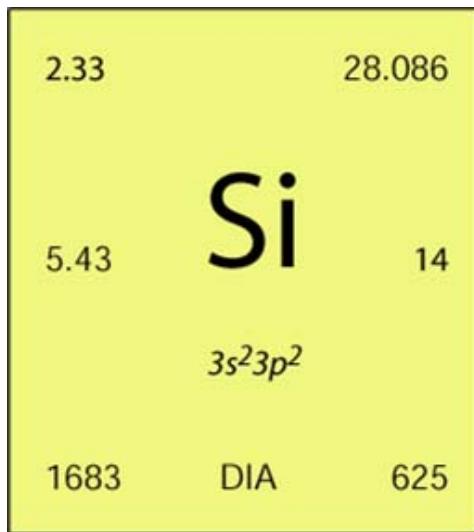
Announcements:

Final exam TA review session: December 16, 7:30-9:30 PM,

Final exam: December 19, 1:30-4:30 PM, duPont; open book, calculator required; entire subject under examination but emphasis on lectures #19-26.

1. Wrap up of 6.012

- *The amazing properties of Si*



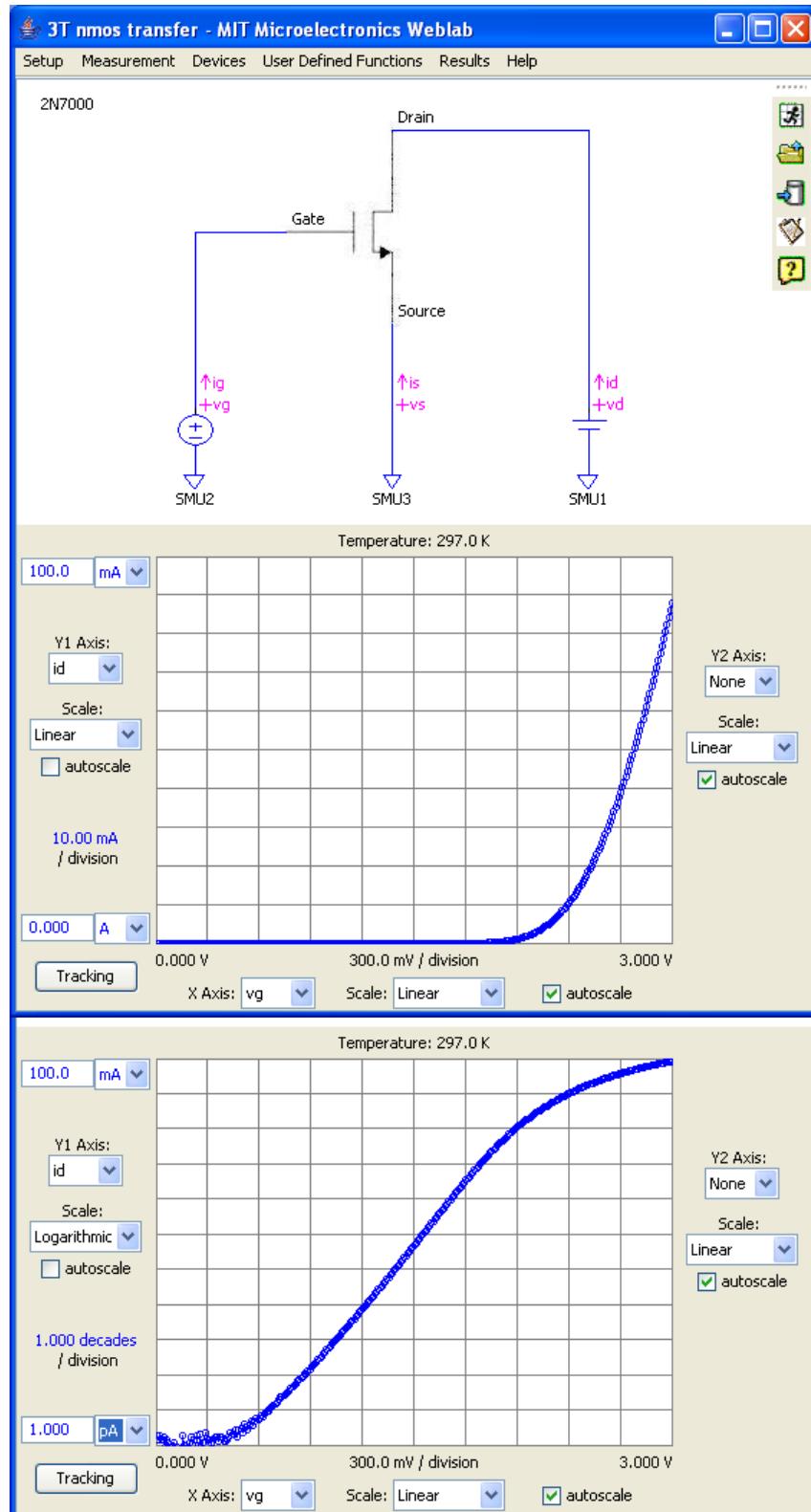
- two types of carriers: electrons and holes
 - however, can make good electronic devices with just one, *i.e.* MESFET (Metal-Semiconductor Field-Effect Transistor), or HEMT (High Electron Mobility Transistor)
 - but, can't do complementary logic (*i.e.* CMOS) without two

- carrier concentrations can be controlled by addition of dopants
 - over many orders of magnitude (about 20!)
 - and in short length scales (nm range)

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37 nm gate length MOSFET from Intel (IEDM '05)

- carrier concentrations can be controlled electrostatically over many orders of magnitude (easily 10!)



- carriers are fast:

- electrons can cross $L = 0.1 \mu m$ in about:

$$\tau = \frac{L}{v_e} = \frac{0.1 \mu m}{10^7 cm/s} = 1 ps$$

- high current density:

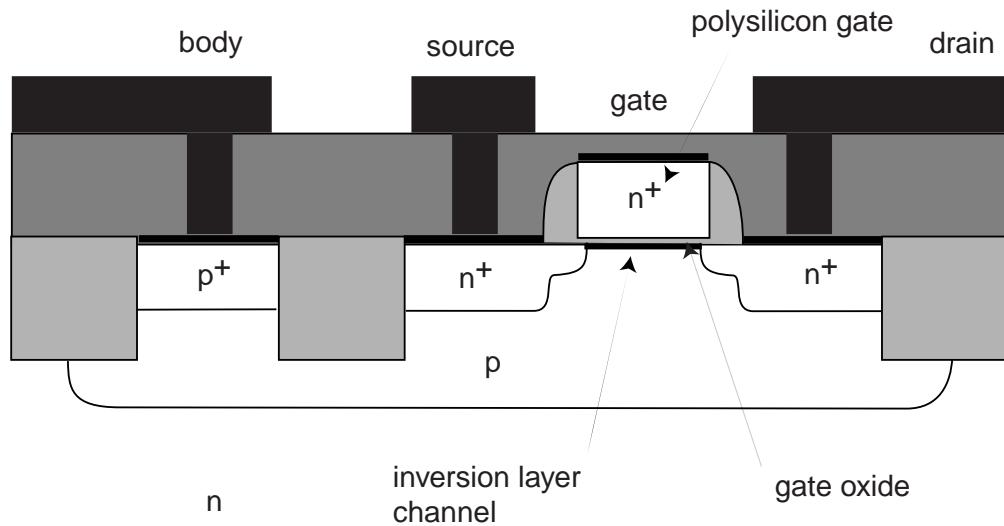
$$\begin{aligned} J_e &= qn v_e = 1.6 \times 10^{-19} C \times 10^{17} cm^{-3} \times 10^7 cm/s \\ &= 1.6 \times 10^5 A/cm^2 \end{aligned}$$

\Rightarrow high current drivability to capacitance ratio

- extraordinary physical and chemical properties

- can control doping over 8 orders of magnitude (p type and n type)
- can make very low resistance ohmic contacts
- can effectively isolate devices by means of pn junctions, trenches and SOI

□ *The amazing properties of Si MOSFET*



• ideal properties of Si/SiO₂ interface:

- can drive surface all the way from accumulation to inversion (carrier density modulation over 16 orders of magnitude)
- not possible in GaAs, for example

- performance improves as MOSFET scales down in size; as $L, W \downarrow$:

— current:

$$I_D = \frac{W}{2L} \mu C_{ox} (V_{GS} - V_T)^2 \text{ unchanged}$$

— capacitance:

$$C_{gs} = WLC_{ox} \downarrow\downarrow$$

— figure of merit for device switching delay:

$$\frac{C_{gs}V_{DD}}{I_D} = L^2 \frac{2V_{DD}}{\mu(V_{GS} - V_T)^2} \downarrow\downarrow$$

- No gate current.
- V_T can be engineered.
- MOSFETs come in two types: NMOS and PMOS.
- Easy to integrate.

□ *The amazing properties of Si CMOS*

- Rail-to-rail logic: logic levels are 0 and V_{DD} .
- No power consumption while idling in any logic state.
- Scales well.

As $L, W \downarrow$:

- Power consumption (all dynamic):

$$P_{diss} = fC_LV_{DD}^2 \propto fWLC_{ox}V_{DD}^2 \downarrow\downarrow$$

- Propagation delay:

$$t_P \propto \frac{C_L V_{DD}}{\frac{W}{L} \mu C_{ox} (V_{DD} - V_T)^2} \downarrow\downarrow$$

- Logic density:

$$Density \propto \frac{1}{A} = \frac{1}{WL} \uparrow\uparrow$$

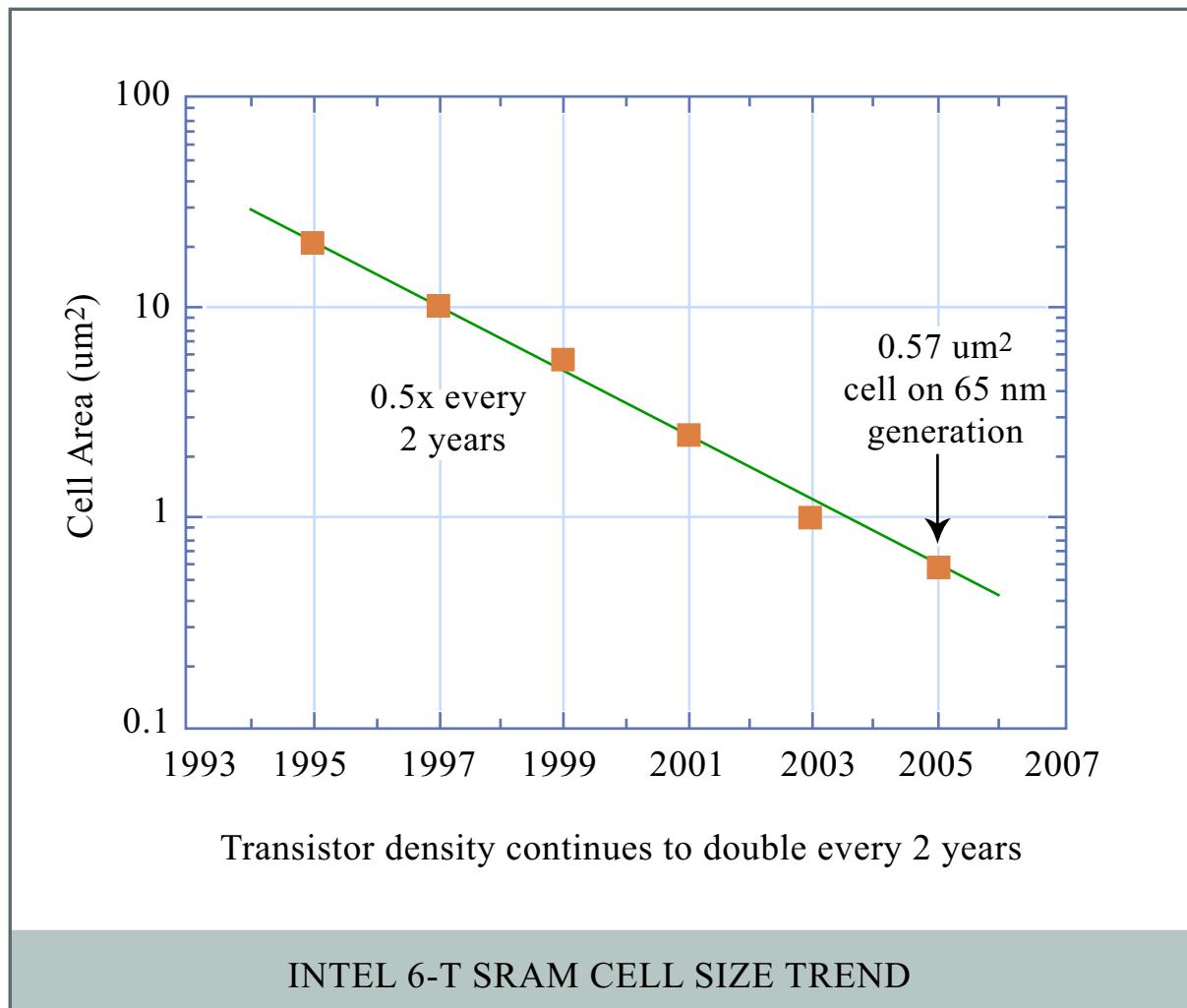


Figure by MIT OCW.

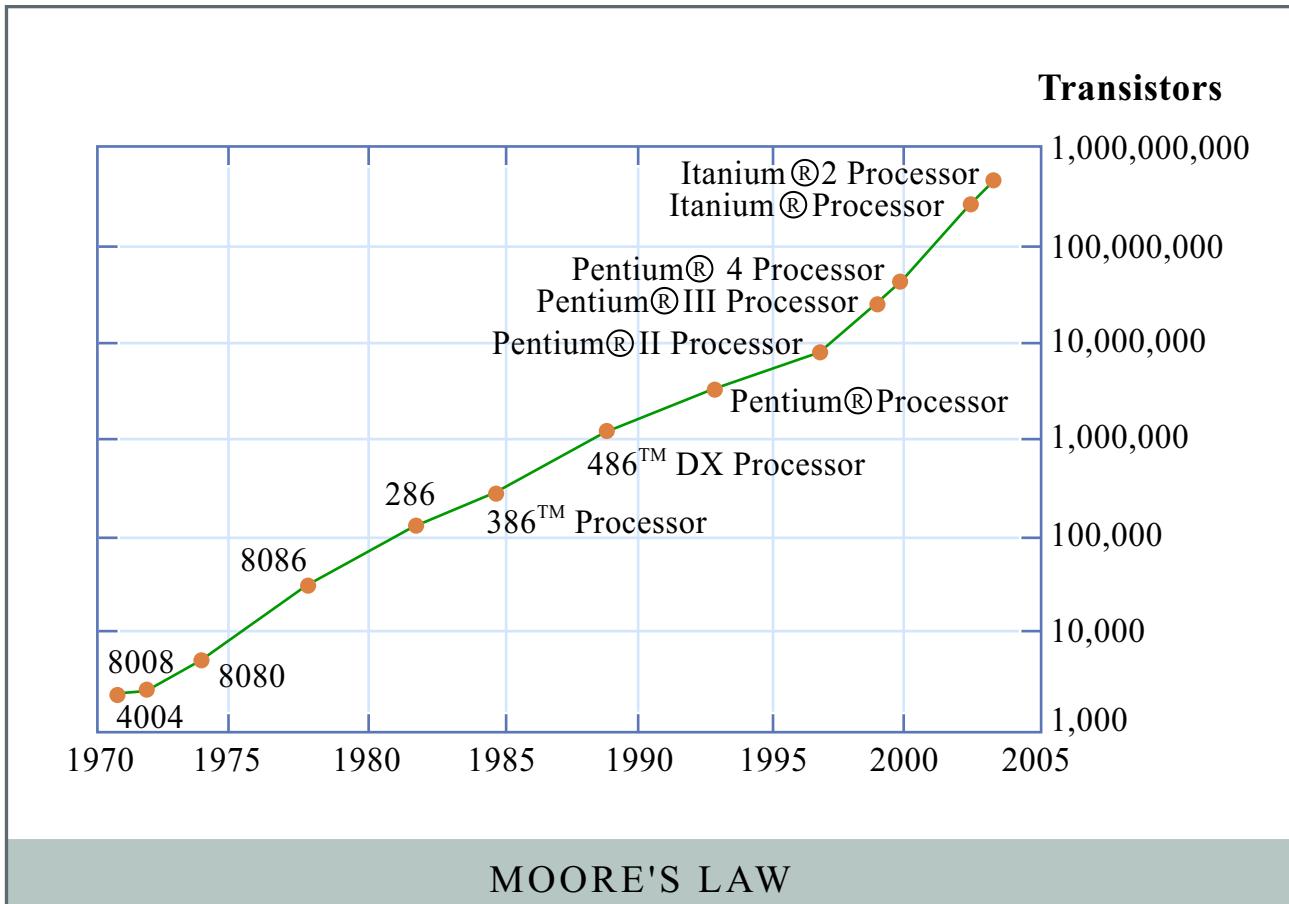


Figure by MIT OCW.

□ MOSFET scaling

Straight MOSFET scaling doesn't work.

- electric field increases

$$E_y \simeq \frac{V_{DD}}{L} \uparrow$$

- power density increases

$$\frac{P_{diss}}{\text{device area}} \propto \frac{f W L C_{ox} V_{DD}^2}{W L} = f C_{ox} V_{DD}^2$$

But

$$t_P \downarrow \downarrow \Rightarrow f \uparrow \uparrow \Rightarrow \frac{P_{diss}}{\text{device area}} \uparrow \uparrow \Rightarrow T \uparrow \uparrow$$

- total power increases

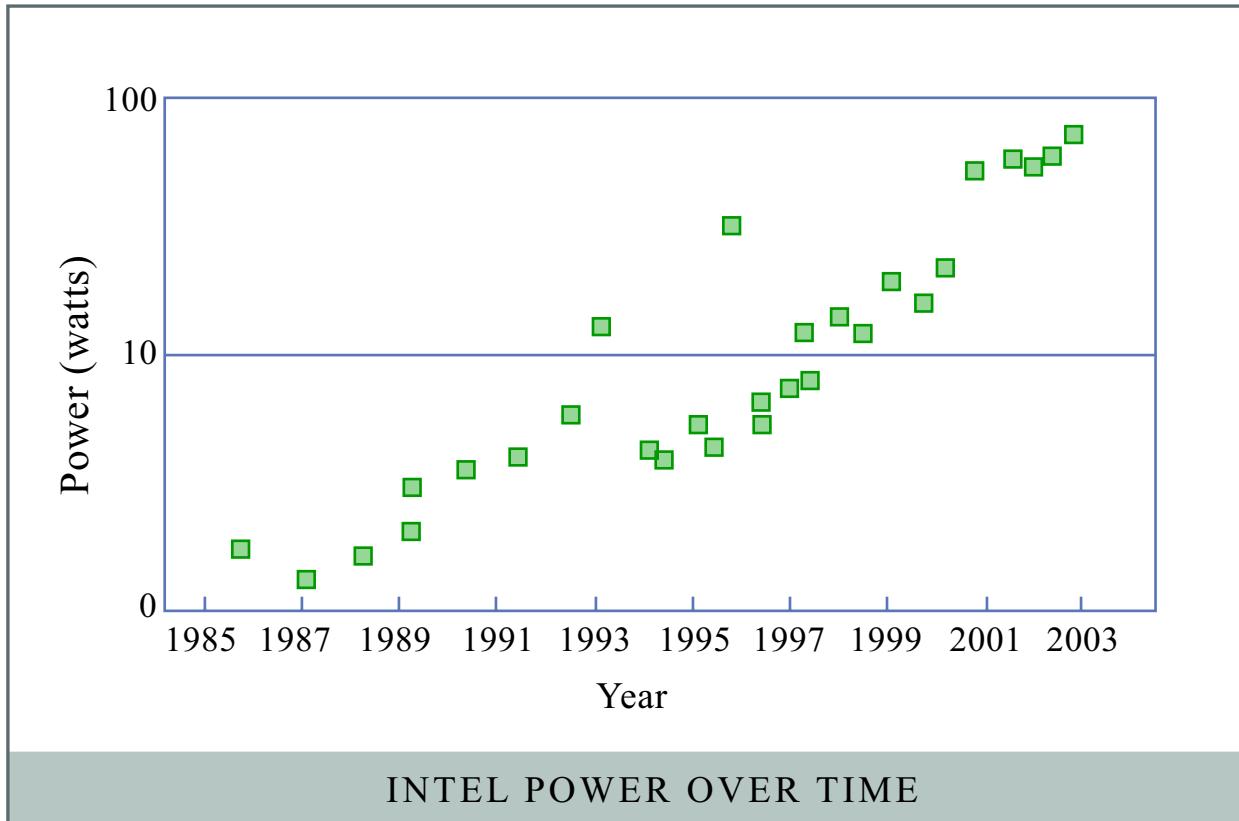
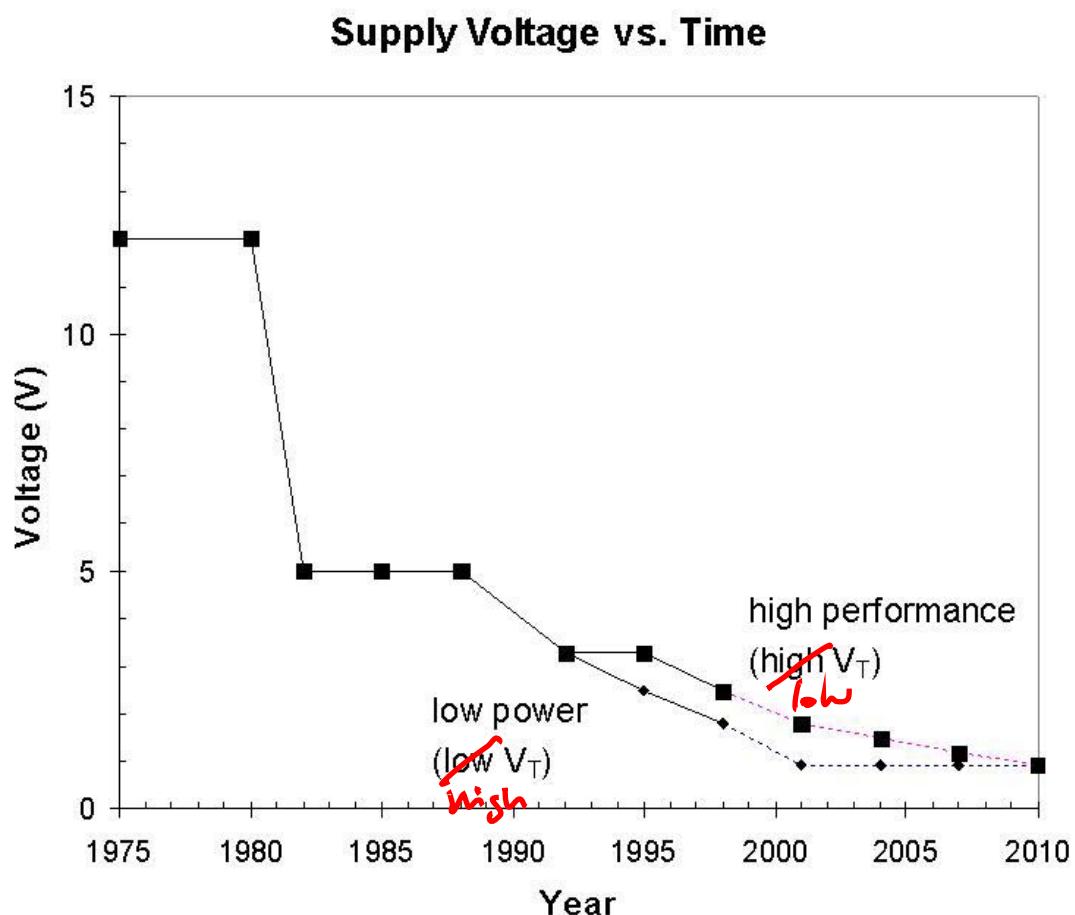


Figure by MIT OCW.

⇒ must scale V_{DD}



Where is this going?

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The future of microelectronics according to Intel:

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□ Exciting times ahead in Si IC technology:

- *analog electronics* (since $\sim 50's$): amplifiers, mixers, oscillators, DAC, ADC, etc.
- *digital electronics* (since $\sim 60's$): computers, microcontrollers, random logic, DSP
- *solid-state memory* (since $\sim 60's$): dynamic random-access memory, flash
- *energy conversion* (since $\sim 70's$): solar cells
- *power control* (since $\sim 70's$): "smart" power
- *communications* (since $\sim 80's$): VHF, UHF, RF front ends, modems, fiber-optic systems
- *sensing, imaging* (since $\sim 80's$): photodetectors, CCD cameras, CMOS cameras, many kinds of sensors
- *micro-electro-mechanical systems* (since $\sim 90's$): accelerometers, movable mirror displays
- *biochip* (from ~ 2000): DNA sequencing, μ fluidics
- *vacuum microelectronics* (from $\sim 2000?$): field-emitter displays
- ??????? (microreactors, microturbines, etc.)

Lots of activity in other semiconductors:

GaN: LED's, high power, high f transistors

GaAs, InP: lasers, detectors for fiber optics communications,

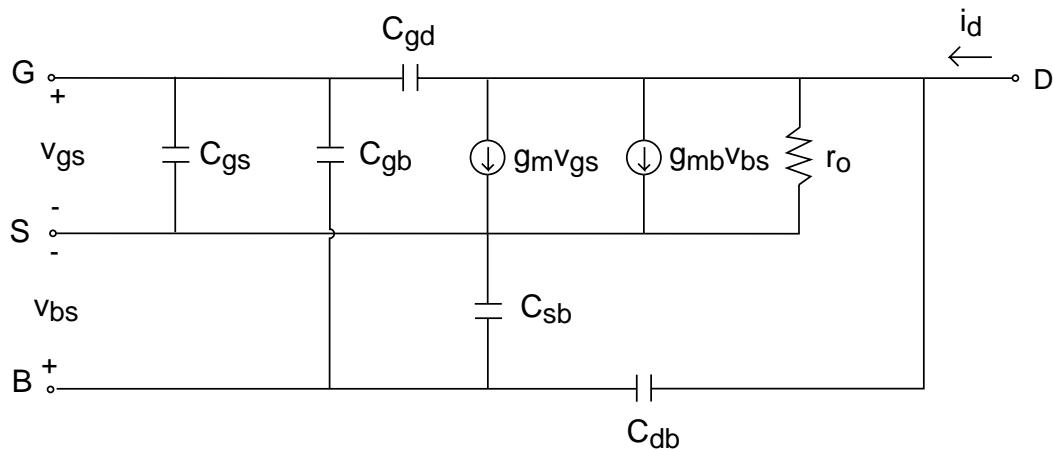
□ Circuit design lessons from 6.012:

1. Importance of optimum level of abstraction:

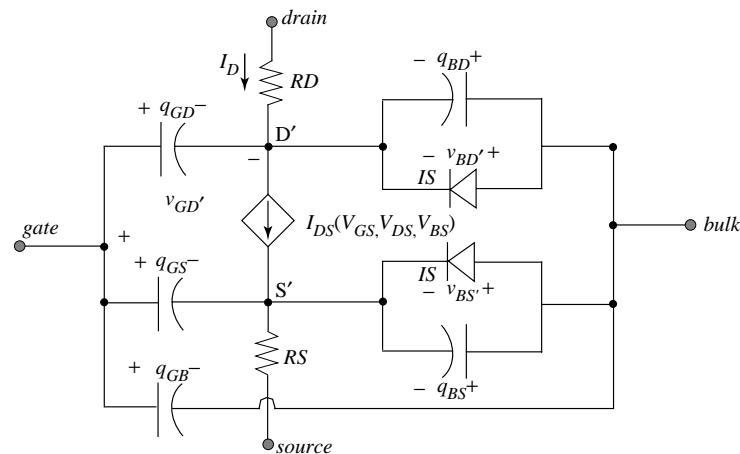
- device physics equations, *i.e.*:

$$I_D = \frac{W}{2L} \mu C_{ox} (V_{GS} - V_T)^2, \text{ etc.}$$

- device equivalent circuit models, *i.e.*:



- device SPICE models, *i.e.*:



2. Many considerations in circuit design:

- multiple performance specs:
 - in analog systems: gain, bandwidth, power consumption, swing, noise, etc.
 - in digital systems: propagation delay, power, ease of logic synthesis, noise, etc.
- need to be immune to temperature variations and device parameter variations (*i.e.*: differential amplifier)
- must choose suitable technology: CMOS, BJT, CBJT, BiCMOS, etc.
- must avoid costly components (*i.e.*: resistors, capacitors)

3. Trade-offs:

- gain-bandwidth trade-off in amplifiers (*i.e.*: Miller effect)
- performance-power trade-off (*i.e.*: delay in logic circuits, gain in amplifiers)
- performance-cost trade-off (cost=design complexity, Si area, more aggressive technology)
- accuracy-complexity trade-off in modeling

- Exciting times ahead in circuit design too:
 - Numbers of transistors available outstrips ability to design by 3 to 1!
 - Operational frequency of logic, analog, and communications circuits increasing very fast.
 - Operational voltage shrinking quickly.
 - New device technologies: GaAs HEMT, InP HBT, GaN HEMT, etc

More subjects in microelectronics at MIT

- *6.152J - Micro/Nano Processing Technology.* Theory and practice of IC technology. Carried out in clean rooms of Microsystems Technology Laboratories. Fulfils Institute or EECS Lab requirement. Fall and Spring.
- *6.301 - Solid-State Circuits.* Analog circuit design. Design project. Spring. G-level.
- *6.334 - Power Electronics.* Power electronics devices and circuits. Spring. H-level.
- *6.374 - Analysis and Design of Digital Integrated Circuits.* Digital circuit design. Design projects. Fall. H-level.
- *6.720J - Integrated Microelectronic Devices.* Microelectronic device physics and design. Emphasis on MOSFET. Design project. Fall. H-level.